SERIAL NO. 10/625,630 FORM PTO-1449 U.S. Department of Commerce (Rev. 4/92) Patent and Trademark Office ATTY. DOCKET NO. L8462.03106 Unassigned INFORMATION DISCLOSURE STATEMENT BY APPLICANT **APPLICANT** (Use several sheets if necessary) A. TAMURA, et al. FILING DATE July 24, 2003 **GROUP** Unassigned **U.S. PATENT DOCUMENTS** EXAMINER FILING DATE **DOCUMENT NUMBER** DATE NAME CLASS **SUBCLASS** 2 5 8 0 8 9 Abrokwah et al. 01/1996

FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

DATE CONSIDERED

09/17/04

EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.